



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Patent Application of
Koichiro TANAKA
Serial No. 09/481,396
Filed: January 12, 2000
For: LASER IRRADIATION
APPARATUS

) Art Unit: 2828
) Examiner: A. Rodriguez

CERTIFICATE OF MAILING

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Washington, D.C. 20231, on 12/26/02

AMENDMENT

Honorable Commissioner of Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated September 25, 2002 please amend the
above-identified application as follows:

IN THE CLAIMS:

Please amend claims 1-7, 10 and 13-14 as follows:

1. (Amended) A laser irradiation apparatus comprising:
- a beam generating unit for emitting a laser beam;
 - a cylindrical lens group for dividing the emitted laser beam in a first direction,
said cylindrical lens group comprising a plurality of cylindrical lenses queuing in said first
direction, each of the cylindrical lenses extending in a second direction which is vertical
to said first direction;
 - an optical system for overlapping divided laser beams; and
 - a slit located between said beam generating unit and said cylindrical lens
group, for making edges of the emitted laser beam straight lines extending parallel to
said second direction of each cylindrical lens.